



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

1763/11  
[10191/1690] #6

RECEIVED

JAN 24 2003

TC 1700

Applicants : BECKER et al.

Serial No. : 09/762,985

Filed : May 8, 2001

For : DEVICE AND METHOD FOR ETCHING A SUBSTRATE  
USING AN INDUCTIVELY COUPLED PLASMA

Examiner : L. Alejandro

Art Unit : 1763

Commissioner for Patents  
Washington, D.C. 20231

we hereby certify that this correspondence is being deposited with  
the United States Postal Service as first class mail in an envelope  
addressed to the Assistant Commissioner for Patents, Washington,  
D.C. 20231, on

Date: 1/16/03

Reg. 41,172

Signature

*D. Magistre*  
DERVIS MAGISTRE  
KENYON & KENYON

ELECTION TRANSMITTAL

SIR:

Please find an Election With Traverse transmitted herewith for filing in the  
above-identified patent application.

Applicants hereby request a three-month extension of time. The extended  
~~period for response expires on January 25, 2003.~~ Please charge the \$930.00 extension fee and  
any other fee that may be required to Deposit Account No. 11-0600. A duplicate of this  
Transmittal is enclosed.

Respectfully submitted,

KENYON & KENYON

*By: D. Magistre*

By: *Richard L. Mayer*

Richard L. Mayer  
Reg. No. 22,490

Dated: 1/16/03

One Broadway  
New York, NY 10004  
(212) 425-7200